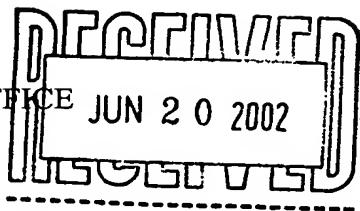




PATENT



In re Application of:
Jong-Dal HONG et al. Group Art Unit: 1762
Serial No.: 10/050,599
Filed: January 18, 2002
For: A PROCESS FOR FABRICATING
MONOLAYER/MULTILAYER
ULTRATHIN FILMS

RECEIVED
JUN 18 2002
TC 1700

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, Applicants bring the disclosures attached and listed on completed Form PTO-1449 to the Examiner's attention and request that they be considered and made of record in this application.

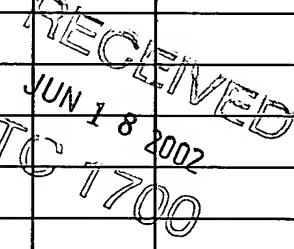
Prompt examination on the merits is respectfully requested.

Respectfully submitted,

David S. Abrams
Reg. No. 22,576

Roylance, Abrams, Berdo & Goodman, L.L.P.
1300 19th Street, N.W., Suite 600
Washington, D.C. 20036
(202) 659-9076

Dated: June 13, 2002

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 43340	SERIAL NO. 10/050,599			
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				APPLICANT Jong-Dale Hong et al.				
				FILING DATE January 18, 2002	GROUP 1762			
JUN 13 2002		U.S. PATENT DOCUMENTS						
EXAMINER INITIALS	SEARCH & EXAMINER INITIALS	DOCUMENT NUMBER		DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
 JUN 18 2002 TC 1700								
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER		DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)								
		"Metal Nanoparticle/Polymer Superlattice Films: Fabrication and Control of Layer Structure"; Schmitt et al., Adv. Mater., 1997, 9, No. 1, pp. 61-65.						
		"The Pseudo-Ordered Structure in Light Emitting Porous and Nanocrystalline Silicon Films", Wang et al., Appl. Phys. Lett., 70(17), 28 April 1997, 2265-2267.						
		"Tuning the Performance of Layer-by-Layer Assembled Organic Light Emitting Diodes by Controlling the Position of Isolating Clay Barrier Sheets", Eckle et al., Nano Letters, 2001, Vol. 1, No. 1, pp. 45-49.						
EXAMINER					DATE CONSIDERED			

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				ATTY. DOCKET NO. 43340 APPLICANT Jong-Dale Hong et al. FILING DATE January 18, 2002		SERIAL NO. 10/050,599 GROUP 1762	
JUN 13 2002 U.S. PATENT DOCUMENTS							
EXAMINER INITIALS PATENTS & TRADEMARKS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<div style="text-align: right; margin-right: 100px;">  JUN 18 2002 TO 1700 </div>							
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	<u>TRANSLATION</u> YES NO	
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)							
	"Mechanism of and Defect Formation in the Self-Assembly of Polymeric Polycation-Montmorillonite Ultrathin Films", Kotov et al., J. Am. Chem. Soc., 1997, 119, 6821-6832.						
	"Electroluminescence Studies on Self-Assembled Films of PPV and CdSe Nanoparticles", Gao et al., J. Phys. Chem. B. 1998, 102, 4096-4103.						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw Line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							